

YOUNGJIN KIM

PhD Candidate

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EDUCATION

B.S.	Electrical and Computer Engineering Seoul National University, Seoul, Republic of Korea Advisor: Byung Gook Park (deceased)	2012. 3 – 2019. 2
M.S. - Ph.D.	Electrical and Computer Engineering Seoul National University, Seoul, Republic of Korea Former advisor: Byoungcho Lee (deceased) Current advisor: Yoonchan Jeong (yoontan@snu.ac.kr)	2019.3 – 2025. 2 (expected)

PROFESSIONAL EXPERIENCE

Visiting Researcher	Stanford University, CA, USA	2023. 12 – 2024. 2
	- Professor: Mark Brongersma, Department of Materials Science and Engineering	
Research Scientist Intern	Meta Reality Labs, Washington, USA	2024. 6 – 2024. 10
	- Department: Optics & Display Research	

JOURNAL PUBLICATIONS

First Author (3)

† : equal contribution

1. **Y. Kim**, G. -Y. Lee, J. Sung, J. Jang, and B. Lee, "[Spiral Metalens for Phase Contrast Imaging](#)," **Advanced Functional Materials**, vol. 32, no. 5, pp. 2106050, 2022.
2. S. -W. Nam†, **Y. Kim†**, D. Kim, and Y. Jeong, "[Depolarized Holography with Polarization-multiplexing Metasurface](#)," **ACM Transactions on Graphics (SIGGRAPH Asia)**, vol. 42, no. 6, article 200, 2023.
3. **Y. Kim†**, T. Choi†, G.-Y. Lee, C. Kim, J. Bang, J. Jang, Y. Jeong, and B. Lee, "Metasurface Folded Lens System for Ultrathin Cameras," **Science Advances**, 2024. (Accepted)

JOURNAL PUBLICATIONS

Co-Author (6)

1. S.-J. Kim, C. Kim, **Y. Kim**, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, "[Dielectric metalens: properties and three-dimensional imaging applications](#)," **Sensors**, vol. 21, no. 13, pp. 4584, 2021.
2. J. Jang, G. -Y. Lee, **Y. Kim**, C. Kim, Y. Jeong, and B. Lee, "[Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range](#)," **IEEE Photonics Journal**, vol. 15, no. 4, pp. 1-9, 2023.
3. C. Kim, J. Hong, J. Jang, G. -Y. Lee, **Y. Kim**, Y. Jeong, and B. Lee, "[Freeform Metasurface Color Router](#)

- [for Deep Sub-micron Pixel Image Sensors](#),” *Science Advances*, vol. 10, no. 22, pp. eadn9000, 2024.
4. H. Son, T. Choi, K. Kim, **Y. Kim**, J. Bang, S.-J. Kim, B. Lee, and Y. Jeong, “[Strong Coupling Induced Bound States in the Continuum in a Hybrid Metal–Dielectric Bilayer Nanograting Resonator](#),” *ACS Photonics*, vol. 11, no. 8, pp. 3221-3232, 2024.
 5. T. Choi, C. Choi, J. Bang, **Y. Kim**, H. Son, C. Kim, J. Jang, Y. Jeong, and B. Lee, “[Multiwavelength Achromatic Deflector in the Visible Using a Single-Layer Freeform Metasurface](#),” *Nano Letters*, vol. 24, no. 35, pp. 10980-10986, 2024.
 6. E. Lee, Y. Jo, S.-W. Nam, M. Chae, C. Chun, **Y. Kim**, Y. Jeong, and B. Lee, “[Speckle Reduced Holographic Display System with a Jointly Optimized Rotating Phase Mask](#),” *Optics Letters*, vol. 49, no. 19, pp. 5659-5662, 2024.
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CONFERENCES

First Author (5)

1. **Y. Kim**, C. Kim, B. Lee, Y. Jeong, and B. Lee, “Meta-optic Miniaturized Telephoto Lens System,” High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. **(Oral presentation)**
 2. **Y. Kim**, C. Kim, and B. Lee, “Phase contrast imaging with multiwavelength achromatic spiral metalens,” OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. **(Oral presentation)**
 3. **Y. Kim**, J. Hong, and B. Lee, “Edge detection metalens with additional spiral phase profiles,” The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. **(Oral presentation)**
 4. **Y. Kim**, C. Kim, and B. Lee, “Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles,” The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
 5. **Y. J. Kim**, J. Hong, J. Sung, and B. Lee, “Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance,” OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.
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HONOR AND AWARDS

- **Seoul National University Joint International Research Grant**
Seoul National University, 2023.
 - **Silver Prize, Samsung Display Industry-Academia Technical Paper Awards**
Samsung Display, 2023.
 - **Scholarship of Foundation for SNU ECE - Kim Jung Sik Fund**
Seoul National University, 2021.
 - **Best Poster Paper Awards**
Optics and Photonics Congress, Jeju, South Korea, 2021.
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RESEARCH EXPERIENCE

- **Metasurfaces / Nano-optics**
 - Physical understanding of nanostructures' optical response
 - Metasurfaces / Nano-optics design using near-field and far-field simulations
 - Hands-on nanofabrication using lithography-techniques
- **Metasurface folded optics**
 - Waveguide-type folded metasurface system design using ray-tracing or wave-optics simulations
 - Hands-on wafer double-side nanofabrication using lithography-techniques
- **Computational design of optical systems leveraging metasurface optics**
 - Metagrating optimization through rigorous coupled-wave analysis using automatic differentiation
 - Joint optimization of metasurface and spatial light modulator (SLM) phase profiles
 - End-to-end optimization of metalens imaging system (Hardware + Software co-design)
 - Metasurface proxy model design for fully differentiable optimization framework
- **Application to imaging system / 3D holographic display / optical neural network**

SKILLS

Numerical simulations

Optical near-field simulations:

RCWA (Python, Pytorch), FEM (COMSOL Multiphysics), FDTD (Lumerical)

Optical far-field simulations:

Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python, Pytorch)

Computational optics design:

Data-driven optimization through machine-learning framework (Pytorch),
Inverse design of periodic nanostructures using automatic-differentiation (Pytorch)

Programming languages & tools:

MATLAB, Python (Pytorch), ZPL (for Zemax)

Experimental experiences

Optical microscopy, Photography, Holographic display with spatial light modulator, Laser/LED-based experiments

Device fabrication

Nanofabrication:

Focused ion beam (FIB) milling, Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporator, Plasma-enhanced chemical vapor deposition (PECVD), Reactive ion etching (RIE)

Measurement:

Scanning electron microscope (SEM), Ellipsometry

Languages

Korean (Native) / English (Fluent)

RESEARCH EXPERIENCE - *Projects*

- **Metalens planar optic system for ultra-slim camera module**
Researcher, Samsung Science & Technology Foundation
Jun. 2020 – July. 2023
 - **Improvement of μ LED optical characteristics using metasurface technology.**
Researcher, Samsung Display
March. 2021 – Feb. 2023
 - **Research for integrated meta-photonics system and its application to mobile real-time 3D imaging**
Researcher, National Research Foundation of Korea
Mar. 2020 - November. 2022
 - **Development of virtual reality technology using metasurface optics**
Researcher, Samsung Display
March. 2020 – Feb. 2021
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